

INTERNATIONAL GEMOLOGICAL INSTITUTE

LABORATORY GROWN DIAMOND REPORT

| September 5, 2024 | |
|---------------------------|--|
| IGI Report Number | LG651438458 |
| Description | LABORATORY GROWN DIAMOND |
| Shape and Cutting Style | CUT CORNERED RECTANGULAR MODIFIED BRILLIANT |
| Measurements | 6.58 X 4.50 X 2.90 MM |
| GRADING RESULTS | |
| Carat Weight | 0.76 CARAT |
| Color Grade | The second s |
| Clarity Grade | VVS 2 |
| ADDITIONAL GRADING IN | NFORMATION |
| Polish | EXCELLENT |
| Symmetry | EXCELLENT |
| Fluorescence | NONE |
| Inscription(s) | (G) LG651438458 |
| Comments: This Laboratory | / Grown Diamond was created by |

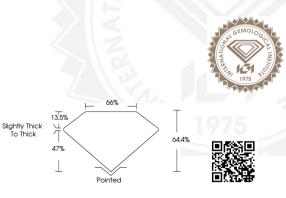
Chemical Vapor Deposition (CVD) growth process. Type IIa

ELECTRONIC COPY

LG651438458



Sample Image Used



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